

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	semiconductor with (grind\$6 adj10 back) with (plasma adj (etch\$6 or lift-off)) with radiat\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 12:22
L3	1	semiconductor with (grind\$6 adj10 back) with (plasma adj (etch\$6 or lift-off)) with (radiat\$6 or irradiat\$6)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 12:21
L4	1	semiconductor with (grind\$6 adj10 back) with (plasma adj (etch\$6 or lift-off)) with (ultraviolet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 12:21
L5	2	semiconductor same (grind\$6 adj10 back) same (plasma adj (etch\$6 or lift-off)) same radiat\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 12:24
L6	0	semiconductor near (grind\$6 adj10 back) near (plasma adj (etch\$6 or lift-off)) near radiat\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 12:22
L7	32	semiconductor and (grind\$6 adj10 back) and (plasma adj (etch\$6 or lift-off)) and radiat\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 13:14
L8	4	semiconductor and (grind\$6 adj10 back) and (plasma adj (etch\$6 or lift-off)) and (ultraviolet adj (radiat\$6 or irradiat\$6))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 12:24
L9	4	semiconductor and (grind\$6 adj10 back) and (plasma adj etch\$6) and (ultraviolet adj (radiat\$6 or irradiat\$6))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 12:24

L10	1694	(438/706).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/22 13:13
L11	2	438/706.ccls. and semiconductor and (grind\$6 adj10 back) and (plasma adj (etch\$6 or lift-off)) and radiat\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 13:14
L12	20	"438"/\$.ccls. and semiconductor and (grind\$6 adj10 back) and (plasma adj (etch\$6 or lift-off)) and radiat\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 13:15
L13	22	"257"/\$.ccls. and semiconductor and (grind\$6 adj10 back) and (plasma adj (etch\$6 or lift-off)) and radiat\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/22 13:15